



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

September 14, 2026

IGI Report Number

LG836667245

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

MODIFIED PEAR STEP CUT

Measurements

8.75 X 5.45 X 3.39 MM

GRADING RESULTS

Carat Weight

1.06 CARAT

Color Grade

F

Clarity Grade

VS 1

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

VERY GOOD

Fluorescence

NONE

Inscription(s)

 LG836667245

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

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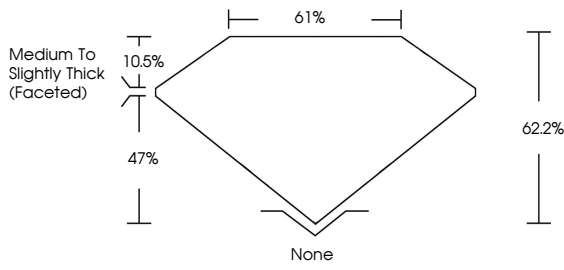
NONE

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PROPORTIONS



Medium To Slightly Thick (Faceted)

61%

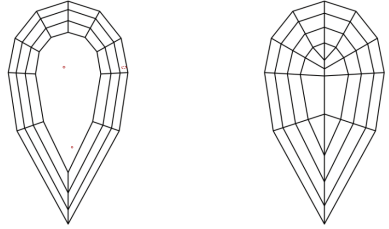
10.5%

47%

62.2%

None

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VS 1-2 VS 1-2 SI 1-2 I 1-3

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included

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Depth

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Table

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Girdle

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Culet

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